

PATENT

D&M File: KCX-771 (19263)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re Application of Eric C. Steindorf |) | Examiner: Nihir B. Patel |
| |) | |
| Serial No: 10/743,260 |) | Art Unit: 3743 |
| |) | |
| Filed: December 22, 2003 |) | Deposit Acct. No: 04-1403 |
| |) | |
| Confirmation No: 4463 |) | Customer No: 22827 |

Title: FACE MASK HAVING BAFFLE LAYER FOR IMPROVED FLUID RESISTANCE

RESPONSE TO FINAL REJECTION

Commissioner for Patents
Box Non-Fee Amendment
Washington, D.C. 20231

Sir:

In view of the Examiner's Final Action of July 19, 2010, applicant hereby responds as follows: